



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

September 13, 2025

IGI Report Number

LG733540717

Description

LABORATORY GROWN DIAMOND

Shape and Cutting Style

SQUARE EMERALD CUT

Measurements

5.65 X 5.62 X 3.80 MM

GRADING RESULTS

Carat Weight

1.15 CARAT

Color Grade

E

Clarity Grade

VS 1

ADDITIONAL GRADING INFORMATION

Polish

EXCELLENT

Symmetry

EXCELLENT

Fluorescence

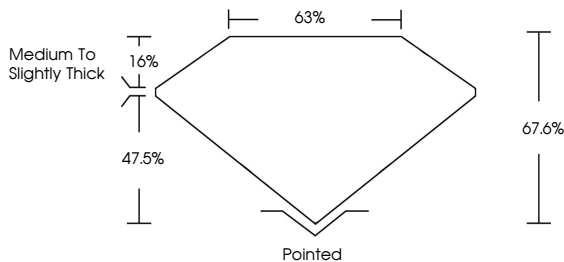
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Inscription(s)

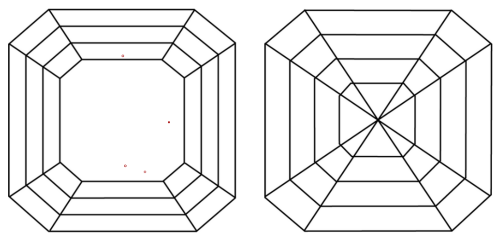
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Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

D E F G H I J Faint Very Light Light

CLARITY

IF VS ¹⁻² VS ¹⁻² SI ¹⁻² I ¹⁻³

Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included

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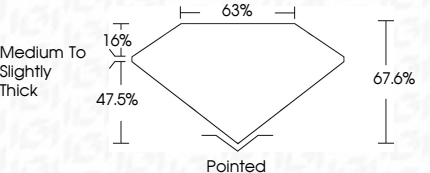
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September 13, 2025

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SQUARE EMERALD CUT

5.65 X 5.62 X 3.80 MM

1.15 CARAT

E

VS 1

67.6%

63%

Medium to Slightly Thick

Pointed

EXCELLENT

EXCELLENT

NONE

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